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	Application No.	Applicant(s)
Notice of Allowability	10/697,676	TRAN ET AL.
	Examiner	Art Unit
	Lynette T. Umez-Eronini	1765
The MAILING DATE of this communication apperature All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT R of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in this or other appropriate communical IGHTS. This application is subjection.	s application. If not included ation will be mailed in due course. THIS
1. This communication is responsive to <u>2/24/2006</u> .		
2. The allowed claim(s) is/are 1-8 and 11-13.		
 3. Acknowledgment is made of a claim for foreign priority una) All b) Some* c) None of the: 1. Certified copies of the priority documents have 2. Certified copies of the priority documents have 3. Copies of the certified copies of the priority do 	e been received. e been received in Application No	D
International Bureau (PCT Rule 17.2(a)).	daments have been received in t	ans national stage application from the
* Certified copies not received:		
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONN THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.	IENT of this application.	
 A SUBSTITUTE OATH OR DECLARATION must be subm INFORMAL PATENT APPLICATION (PTO-152) which give 		
5. \boxtimes CORRECTED DRAWINGS (as "replacement sheets") must		
(a) 🛛 including changes required by the Notice of Draftspers		TO-948) attached
1) ⊠ hereto or 2) ☐ to Paper No./Mail Date <u>2/26/2</u>		
(b) ☐ including changes required by the attached Examiner' Paper No./Mail Date Identifying indicia such as the application number (see 37 CFR 1		
each sheet. Replacement sheet(s) should be labeled as such in t	the header according to 37 CFR 1.	121(d).
 DEPOSIT OF and/or INFORMATION about the depo attached Examiner's comment regarding REQUIREMENT 	sit of BIOLOGICAL MATERIA FOR THE DEPOSIT OF BIOLOG	AL must be submitted. Note the GICAL MATERIAL.
Attachment(s) 1. ☐ Notice of References Cited (PTO-892)		al Patent Application (PTO-152)
2. Notice of Draftperson's Patent Drawing Review (PTO-948)	6. ⊠ Interview Summ Paper No./Mail	
 Information Disclosure Statements (PTO-1449 or PTO/SB/C Paper No./Mail Date 1/9,11,12/6;2/24/6 	08), 7. ⊠Examiner's Ame	
Examiner's Comment Regarding Requirement for Deposit of Biological Material	8. 🛛 Examiner's State	ement of Reasons for Allowance
•	9.	
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DETAILED ACTION

Request for Continued Examination Application

1. A request for continued examination under 37 CFR 1.114, including the fee set forth in 37 CFR 1.17(e), was filed in this application after allowance or after an Office action under *Ex Parte Quayle*, 25 USPQ 74, 453 O.G. 213 (Comm'r Pat. 1935). Since this application is eligible for continued examination under 37 CFR 1.114, and the fee set forth in 37 CFR 1.17(e) has been timely paid, prosecution in this application has been reopened pursuant to 37 CFR 1.114 to reconsider IDS filed 1/9/2006, 1/11/2006, 1/12/2006, and 2/24/2006. Applicant's submission filed on 2/24/2006 has been entered.

EXAMINER'S AMENDMENT

2. An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

Authorization for this examiner's amendment was given in a telephone interview with Yingsheng Tung on 3/9/2006.

The application has been amended as follows:

Cancel non-elected claims 9-10.

3. The following is an examiner's statement of reasons for allowance:

As to claims 1-8 and 11-13, the prior art of record taken alone or in combination fails to suggest, teach, or render obvious a chemical mechanical polishing process for removing material from a wafer surface of a semiconductor comprising: providing a polishing recipe, which is based on the topography of the wafer surface, wherein the recipe includes directing a portion of the wafer to reside in a channel-free portion of a polishing pad during a portion of the process, in combination with the rest of the limitations of the claims.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Lynette T. Umez-Eronini whose telephone number is 571-272-1470. The examiner is normally unavailable on the First Friday.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Nadine Norton can be reached on 571-272-1465. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only.

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For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

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March 12, 2006

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